Application Number:	094	09412510					
Filing Date:	05-	05-Oct-1999					
Title of Invention:	PR	PROCESS FOR TREATING A SUBSTRATE WITH A PLASMA					
First Named Inventor:	KE	KENJI ITOH					
Filer:	Joh	John Francis Guay					
Attorney Docket Number:	075	0756-2045					
Filed as Large Entity							
Utility Filing Fees							
Description		Fee Code	Quantity	Amount	Sub-Total in USD(\$)		
Basic Filing:							
Pages:							
Claims:							
Miscellaneous-Filing:							
Petition:							
Patent-Appeals-and-Interference:							
Post-Allowance-and-Post-Issuance:							
	-						

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
	Total in USD (\$)			130